Multimodal Electrothermal Silicon Microgrippers for Nanotube Manipulation (vol 8, pg 76, 2009)

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Total number of authors:

11

Published in:

I E E E Transactions on Nanotechnology

Link to article, DOI:

[10.1109/TNANO.2009.2031448](https://doi.org/10.1109/TNANO.2009.2031448)

Publication date:

2009

Document Version

Publisher's PDF, also known as Version of record

[Link back to DTU Orbit](#)

Citation (APA):

Nordström Andersen, K., Petersen, D. H., Carlson, K., Mølhave, K., Sardan Sukas, Ö., Horsewell, A., Eichhorn, V., Fatikow, S., Bu, I. Y. Y., Milne, W. I., & Bøggild, P. (2009). Multimodal Electrothermal Silicon Microgrippers for Nanotube Manipulation (vol 8, pg 76, 2009). *I E E E Transactions on Nanotechnology*, 8(5), 659-659. <https://doi.org/10.1109/TNANO.2009.2031448>

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Correction

Correction to “Multimodal Electrothermal Silicon Microgrippers for Nanotube Manipulation”

Karin Nordström Andersen, D. H. Petersen, K. Carlson, K. Mølhave, Ozlem Sardan, A. Horsewell, Volkmar Eichhorn, Sergej Fatikow, *Member, IEEE*, and Peter Bøggild

Owing to an error in the final phase of submitting the publication-ready document of the original paper [1], two authors' names were omitted from the author listing. The correct author listing is as follows:

Manuscript received July 03, 2009. Current version published September 04, 2009.

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Digital Object Identifier 10.1109/TNANO.2009.2031448

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- [1] K. N. Andersen, D. H. Petersen, K. Carlson, K. Mølhave, O. Sardan, A. Horsewell, V. Eichhorn, S. Fatikow, and P. Bøggild, “Multimodal electrothermal silicon microgrippers for nanotube manipulation,” *IEEE Trans. Nanotechnol.*, vol. 8, no. 1, pp. 76–85, Jan. 2009.